



Docket No.: SON-2563
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Koichiro SAGA

Application No.: 10/501,155

Confirmation No.: 5207

Filed: July 13, 2004

Art Unit: 1792

For: SURFACE TREATMENT METHOD,
SEMICONDUCTOR DEVICE, METHOD OF
FABRICATION SEMICONDUCTOR DEVICE
AND TREATMENT APPARATUS

Examiner: Joy L. Watson

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In full and timely response to the non-final Office Action dated December 3, 2007,
please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks/Arguments begin on page 10 of this paper.